

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
(Case No. 98,162-B)

In re Application of:

DeGendt, et al.

Serial No.: 09/207,546

Filed: December 8, 1998

For: METHOD FOR REMOVING ORGANIC
CONTAMINANTS FROM A
A SEMICONDUCTOR SURFACE

) Group Art Unit: 1746

) Examiner: Ahmed

Commissioner for Patents
Washington, D.C. 20231

PRELIMINARY AMENDMENT

Dear Sir:

In response to the outstanding Office Action mailed March 22, 2001, please enter
the following remarks and amendments in the above-referenced patent application.

IN THE CLAIMS

Please amend claim 27 as follows. A marked up version of the amended claim, to show
all the changes, is attached hereto on pages separate from the amendment in accordance with 37
CFR 1.121(c)(1)(ii).

B
27. (Amended) A method for removing organic contaminants from a substrate, the
organic contaminants resulting from a previous lithographic step, the method comprising the
steps of:

holding said substrate in a tank; and

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